

Notice of References Cited	Application/Control No. 10/643,900	Applicant(s)/Patent Under Reexamination TAKASHI IIZUKA ET AL.	
	Examiner Hai C. Pham	Art Unit 2861	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,841,463	11-1998	Debasis et al.	347/242
*	B	US-6,667,757	12-2003	Yamaguchi et al.	347/259
*	C	US-5,680,242	10-1997	Ando, Toshinori	359/196
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
	O					
	P					
	Q					
	R					
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	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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